



02/18/00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
 Assistant Commissioner for Patents
 Washington, D.C. 20231

Re. Inventor(s): Shen, et al.
 Title: Self-Cleaning Process for Etching Silicon-Containing Material

jc530 U.S. PTO
 09/507629
 02/18/00

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 27 pages.
- ☒ Drawings totaling 3 pages, X Formal Informal.
- ☐ Executed Declaration and Power of Attorney.
- ☒ Information Disclosure Statement, PTO-1449 form, and copies of citations
- ☐ Assignment of the invention to **Applied Materials, Inc.** and Assignment Recordation Cover Sheet
- ☒ Post Card for return

FEE CALCULATION

Fee Items	Claims Filed	Included with Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	43	- 20 =	23	x 18.00	
Independent Claims	4	- 3 =	1	x 78.00	
Basic Filing Fee				690.00	
TOTAL FEES					\$ 0.00

- ☐ The Commissioner is hereby authorized to charge \$_____ to Deposit Account No. **50-1074**.
- ☐ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. **50-1074**. A duplicate copy of this transmittal is enclosed.
- ☒ Please address all future correspondence to: **APPLIED MATERIALS, INC.**
Patent Department
P.O. Box 450A
Santa Clara, CA 95052

A copy of this document is being furnished to the Commissioner of Patents and Trademarks, U.S. Patent and Trademark Office, Washington, D.C. 20231.

Express Mail Receipt No. EM572428882US

Date of Deposit February 18, 2000

Ashok K. Janab
 Registration No. 57,487